

European XFEL Overview technical layout

R. Brinkmann



R. Brinkmann, DESY EIFast workshop, May 9/10, 2006

Introduction

Proposal Oct. 2002 – X-ray FEL user facility with 20 GeV superconducting linear accelerator in TESEA technology

Approval by German government Feb. 2003 as European Project Commitment for 50% of funding + expected max.10% by Hamburg & Schleswig-Holstein, at least 40% European & international partners



TESLA XFEL

First Stage of the X-Ray Laser Laboratory

Technical Design Report

Supplement



October 2002



Introduction cont'd

- Project preparation phase: get ready to start construction of the facility before end 2006
 - Finalize overall layout and technical design
 - Detailed planning for the new site near DESY
 - Industrialization of major technical components
 - Update of project construction and operation cost estimate
 - Project organization at the European/International level



Project Preparation Group @ DESY



38 Work Packages each WP coordinated by a WP Leader



Introduction cont'd

TESLA Test Facility and the VUV-FEL:



→ Pilot facility regarding practically all aspects (accelerator technology, beam physics, FEL process, user operation) of the XFEL

→Test bed for technical developments specifically required for the XFEL

→ PITZ facility (DESY-Zeuthen) for injector development



Properties of XFEL radiation

X-ray FEL radiation (0.2 - 14.4 keV)

- ultrashort pulse duration <100 fs (rms)
- extreme pulse intensities 10¹²-10¹⁴ ph
- coherent radiation x10⁹
- average brilliance x10⁴

Spontaneous radiation (20-200 keV)

- ultrashort pulse duration <100 fs (rms)
- high brilliance





The European X-Ray Laser Project X-Ray Free-Electron Las









Beam lines



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Acc. layout & parm's cont'd

Energy for 0.1nm wavelength (max. design energy)	17.5 GeV (20 GeV)
# of installed accelerator modules	116
# of cavities	928
Acc. Gradient (104 active modules) at 20 GeV	23.6 MV/m
# of installed RF stations	29
Klystron peak power (26 active stations)	5.2 MW
Loaded quality factor Q _{ext}	$4.6 \cdot 10^6$
RF pulse length	1.4 ms
Beam pulse length	0.65ms
Repetition rate	10 Hz
Max. average Beam power	600 kW
Unloaded cavity quality factor Q_0	10^{10}
2K cryogenic load (including transfer line losses)	1.7 kW
Max. # of bunches per pulse (at 20 GeV)	$3,250(3,000)^{1}$
Min. bunch spacing	200 ns
Bunch charge	1 nC
Bunch peak current	5 kA
Emittance (slice) at undulator	1.4 mm*mrad
Energy spread (slice) at undulator	1 MeV

1) The limitation to 3,000 bunches at 20 GeV beam energy is related to a maximum load of 300 kW on each of the beam dumps in the initially installed two electron beam lines.



Operational flexibility & upgrade options

Energy variation:

change acc gradient only in main linac (keep low energy section up to 2nd BC unchanged)

post-linac beam lines are designed for $\pm 1.5\%$ dynamic acceptance \rightarrow wavelength scan within a pulse train possible

Expect performance of electropolished s.c. cavities better than baseline design specs \rightarrow potential for higher energy/shorter wavelength

RF and cryogenic systems can support linac operation up to ~ 24GeV (28MV/m), post-linac beam lines laid out for up to 25GeV



Overhead designed into tech sub-systems also permits higher duty cycle/rep rate of the linac (*if* injector can support that) – depending on beam energy:

Assumption: RF and cryogenic systems operated at 80% of design limit





Different beam time structure to different experiments – concept using kicker devices permits large flexibility without having to change the (preferably homogenous) bunch train structure in the linac





CW operation, only possible at lower beam energy, can become a future option if:

high duty cycle at longer wavelength is desirable

improved beam quality + different undulators permit 0.1nm wavelength FEL at lower beam energy

CW beam time structure attractive for experiments which require high average intensity but can not operate with the high bunch frequency (max 5MHz) of the pulsed machine





- No detailed design yet, but certain aspects to facilitate CW option:
 - Space & infrastructure for 2nd injector
 - Lower acc gradient in first section of acc (up to 2nd BC)
 - Space in tunnel for additional CW RF system
 - Tunable RF coupling to cavities
 - ERL mode not excluded (cavity spacing, module length)
- Sketch of possible parameters:

Beam energy	7 GeV	
Accelerating Gradient	7.5 MV/m	
# of CW RF stations	116	
RF power per accelerator module	≈20 kW	
Beam current	0.18 mA	
Loaded quality factor Q _{ext}	2.10^{7}	
Bunch frequency	180 kHz	
Unloaded quality factor Q_0	$2 \cdot 10^{10}$	
2K cryogenic load	≈3.5 kW	





More on acc. collaboration (not exhaustive):

- Within XFEL preparation: PSI on beam stabilization system (2nd workshop March 2006), Swedish Univ. on special diagnostics (started), magnets and vac chamber surface (in prep.)
- EUROFEL: CW, modules, injector, synchronization,...
- PITZ collaboration (DESY-Zeuthen)
- Relation to ILC: clearly organizationally separated projects (different communities, different time-line for realization), but:
 - Keeping in mind (on both sides) the possible synergies and making the best out of this can be at least as beneficial as keeping the projects strictly separate





XFEL s.c. Cavities

cavity material		RRR 300 niobium
type of accelerating structure		standing wave
accelerating mode		TM010, π-mode
fundamental frequency	<i>f_{RF}</i> [MHz]	1,300
active length	L [m]	1.038
nominal gradient	E _{acc} [MV/m]	23.6
quality factor	Q ₀	>10 ¹⁰
cell-to-cell coupling	<i>K_{cc}</i> [%]	1.87
iris diameter	[mm]	70



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Cavity Fabrication





5



Large-grain cavity R&D

- possible alternative fabrication method: cut Nb sheets directly from ingot (pioneered by P. Kneisel, Jlab)
- Promising initial results for single cells
- 9-cells in preparation
- Need decision by ~ beginning 2007



41 MV/m, Q₀=2x10¹⁰ at 1.8K







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1. electro-chemical removal of a thick niobium layer (so-called damage layer) of about 150 µm from the inner surface

2. a rinse with particle free / ultra-pure water to remove residues form the electro-chemical treatment

- 3. outside etching of the cavities of about 20 µm
- 4. ultrahigh vacuum annealing at 800°C
- 5. tuning of the cavity frequency and field profile
- 6. removal of a thin and final layer of about 30 μm
- 7. rinsing with particle free / ultra pure water at high pressure (100 bar) to remove surface contaminants
- 8. assembly of auxiliaries (pick-up probe and HOM pick-up)
- 9. baking at 120°C in ultra high vacuum
- 10. additional six times rinse with high pressure ultra-pure water (100 bar)







Single Module-Testbench

- Necessary for accelerator module prototype & pre-series tests on the way to series production without interfering with FLASH (VUV-FEL) operations
- Commissioning June 2006, module #6 (→ FLASH autumn 2006) will be first tested
- Larger test facility (cavities, modules and RF components) foreseen for XFEL series production







The European XFF X-Ray Laser Project X-Ray Free-Elect **High Power RF System** (Modulator, Pulse Cable, Pulse Transformer, Klystron) L1 10 kV S1 CHARGING $\overline{}$ 3 H 70 kJ ⁺| 1400 μF 100 80Ω ∄моч иF 1:12 Pulse Transformer C2 2 mF + L2 330 μH 2900 1560 330 \bot D 600



Low Level RF Control







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A re-evaluation of construction cost started in 2005. For the accelerator, infrastructure & civil construction it was completed in Jan. 2006 and reviewed (STI-committee) in March 06 (review of photon part May 22/23 2006). The resulting (status March 2006) project construction cost for the facility in its configuration as described in the TDR draft amounts to **974 M€**, 750 M€ for capital investment and 224 M€ for personnel.





Cost distribution accelerator complex:

261 M€ cap invest

85 M€ personnel

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Budget profile for construction (y2005 basis, preliminary) Overlapping commissioning & operation budget will start mid-2013

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